



US00D734730S

(12) **United States Design Patent**
Yoshida et al.

(10) **Patent No.:** **US D734,730 S**
(45) **Date of Patent:** **** Jul. 21, 2015**

(54) **BOAT OF SUBSTRATE PROCESSING APPARATUS**

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(**) Term: **14 Years**

(21) Appl. No.: **29/459,104**

(22) Filed: **Jun. 26, 2013**

(30) **Foreign Application Priority Data**

Dec. 27, 2012 (JP) 2012-031874

(51) **LOC (10) CL.** **13-03**

(52) **U.S. CL.**
USPC **D13/182**

(58) **Field of Classification Search**
USPC D13/182; D15/144, 144.1, 199;
118/715, 500, 728, 729; 211/41.18;
432/253, 258; 156/345.51, 345.52,
156/345.53, 345.55; 414/217, 220.01, 935,
414/936-941
CPC C23C 16/458; C23C 16/4581; C23C
16/4582; C23C 16/4583; C23C 16/4584;
C23C 16/4586; C23C 16/4587; C23C
16/4588; C30B 31/14; H01L 21/673; H01L
21/67303; H01L 21/67306; H01L 21/67309;
H01L 21/67313; H01L 21/67316; H01L
21/67323; H01L 21/67326; H01L 21/6733

See application file for complete search history.

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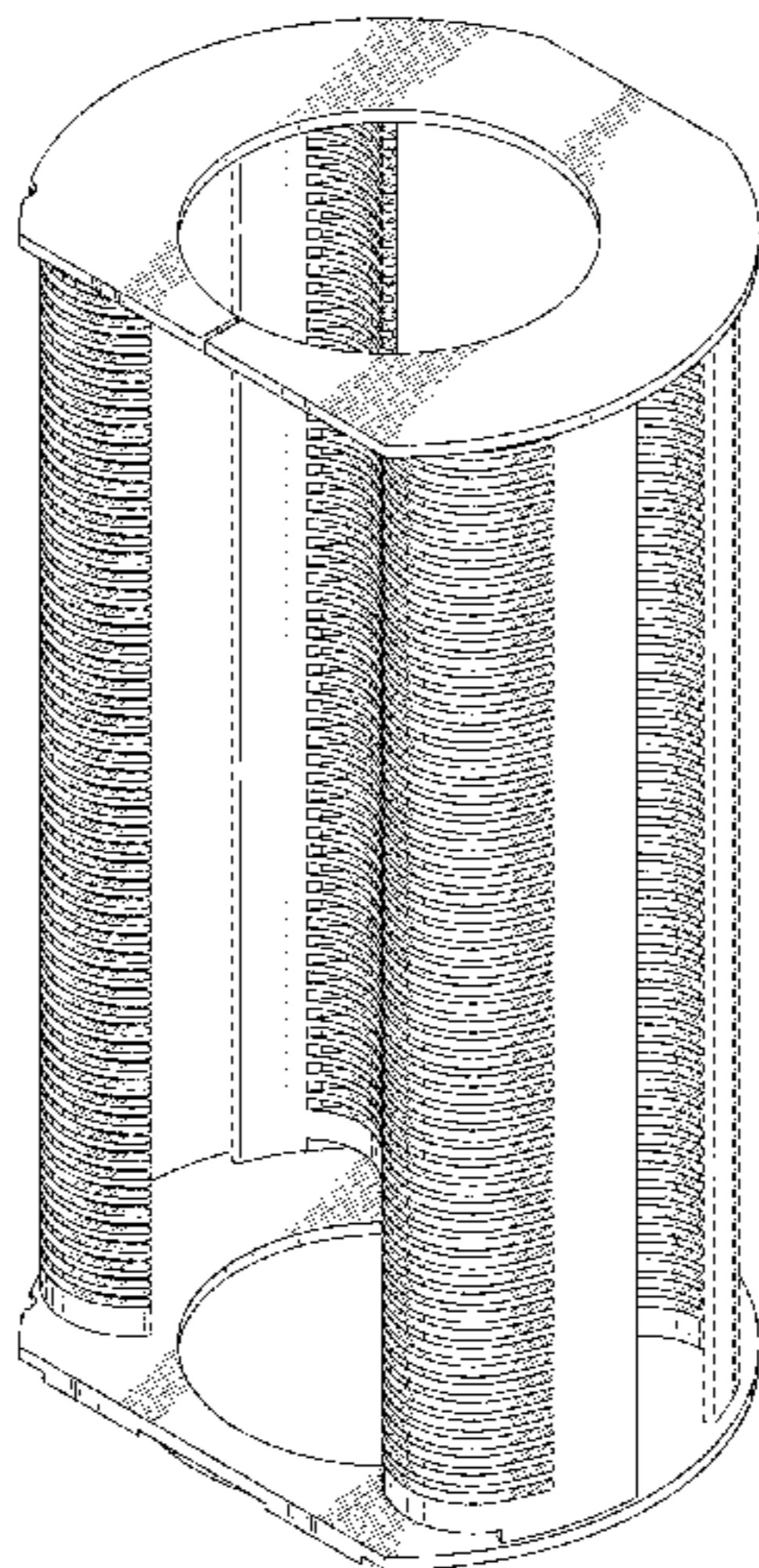
(57) **CLAIM**

The ornamental design for a boat of substrate processing apparatus, as shown.

DESCRIPTION

FIG. 1 is a front, top and right side perspective view of a boat of substrate processing apparatus showing our new design; FIG. 2 is a rear, top and left side perspective view thereof; FIG. 3 is a front elevational view thereof; FIG. 4 is a rear elevational view thereof; FIG. 5 is a left side elevational view thereof; FIG. 6 is a right side elevational view thereof; FIG. 7 is a top plan view thereof; FIG. 8 is a bottom plan view thereof; FIG. 9 is a cross sectional view taken along line 9-9 in FIG. 3; and, FIG. 10 is a cross sectional view taken along line 10-10 in FIG. 3.

1 Claim, 9 Drawing Sheets



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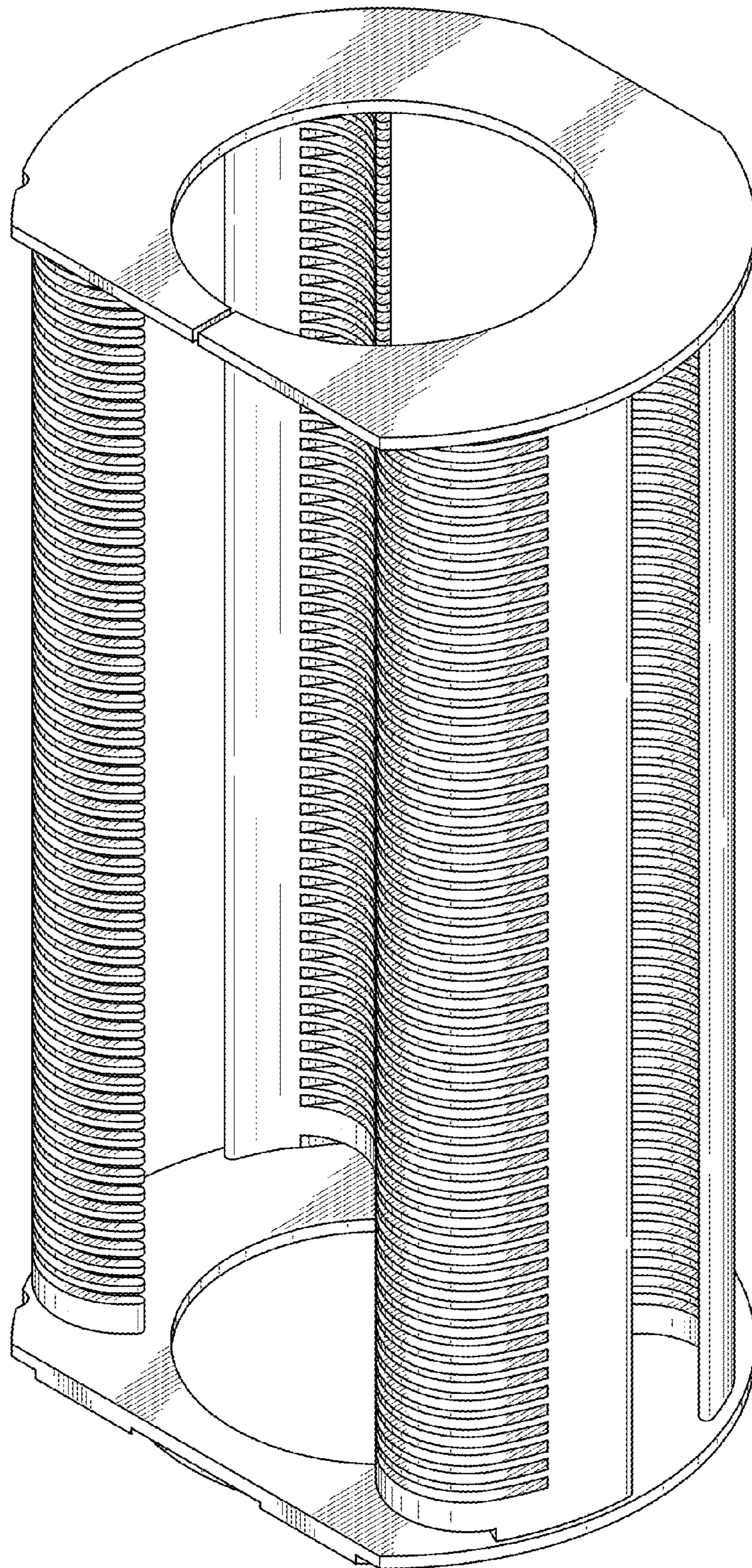


FIG. 1

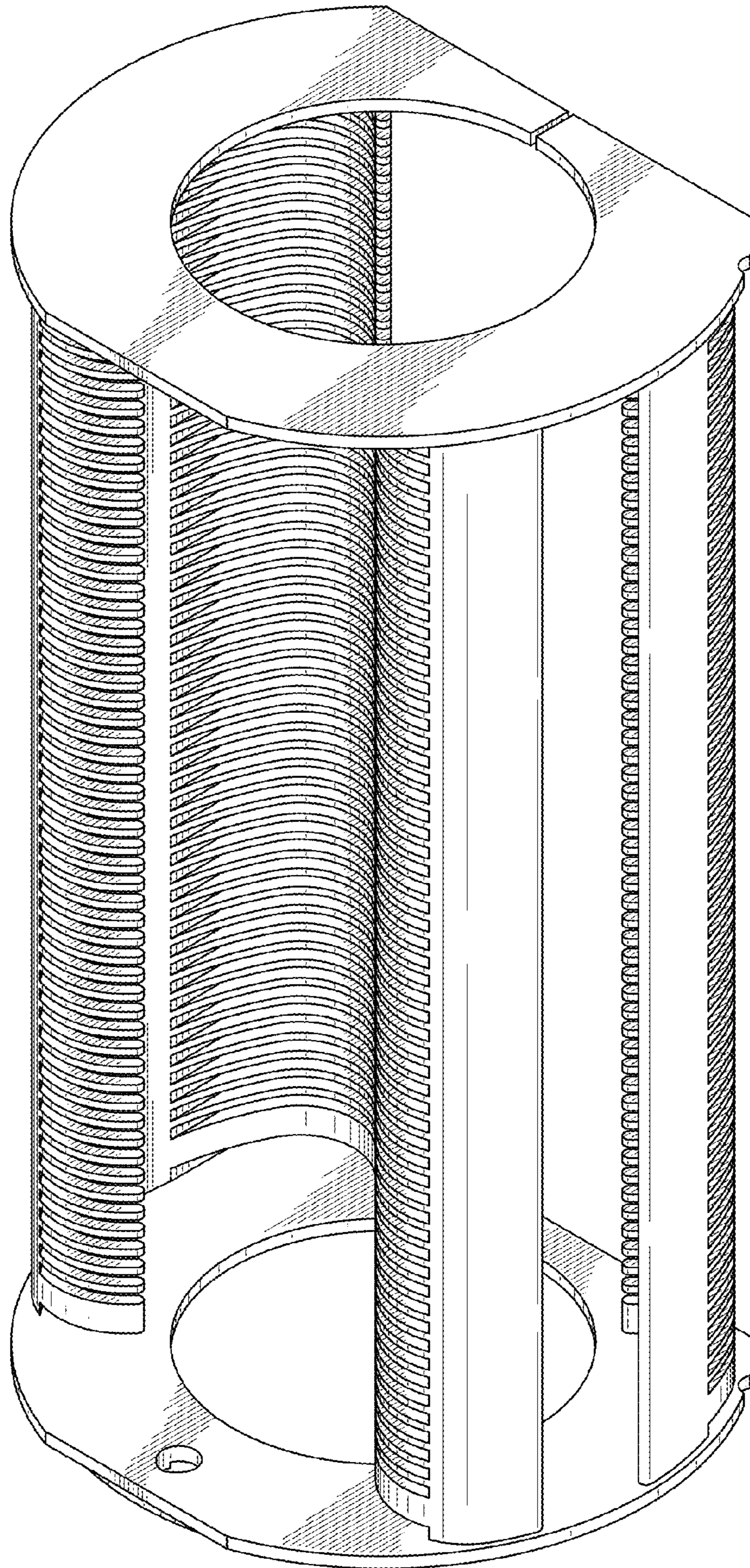
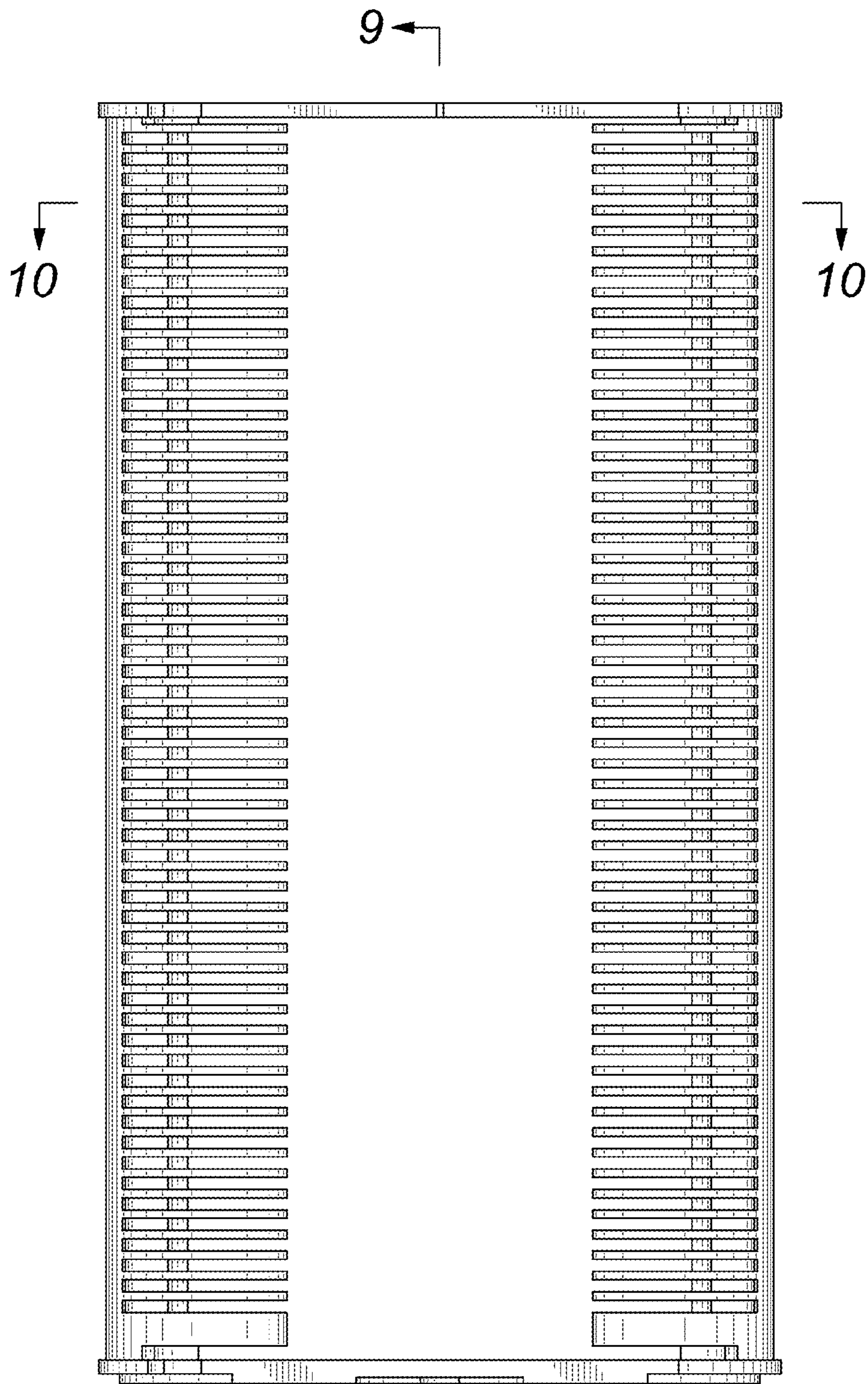


FIG. 2



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FIG. 3

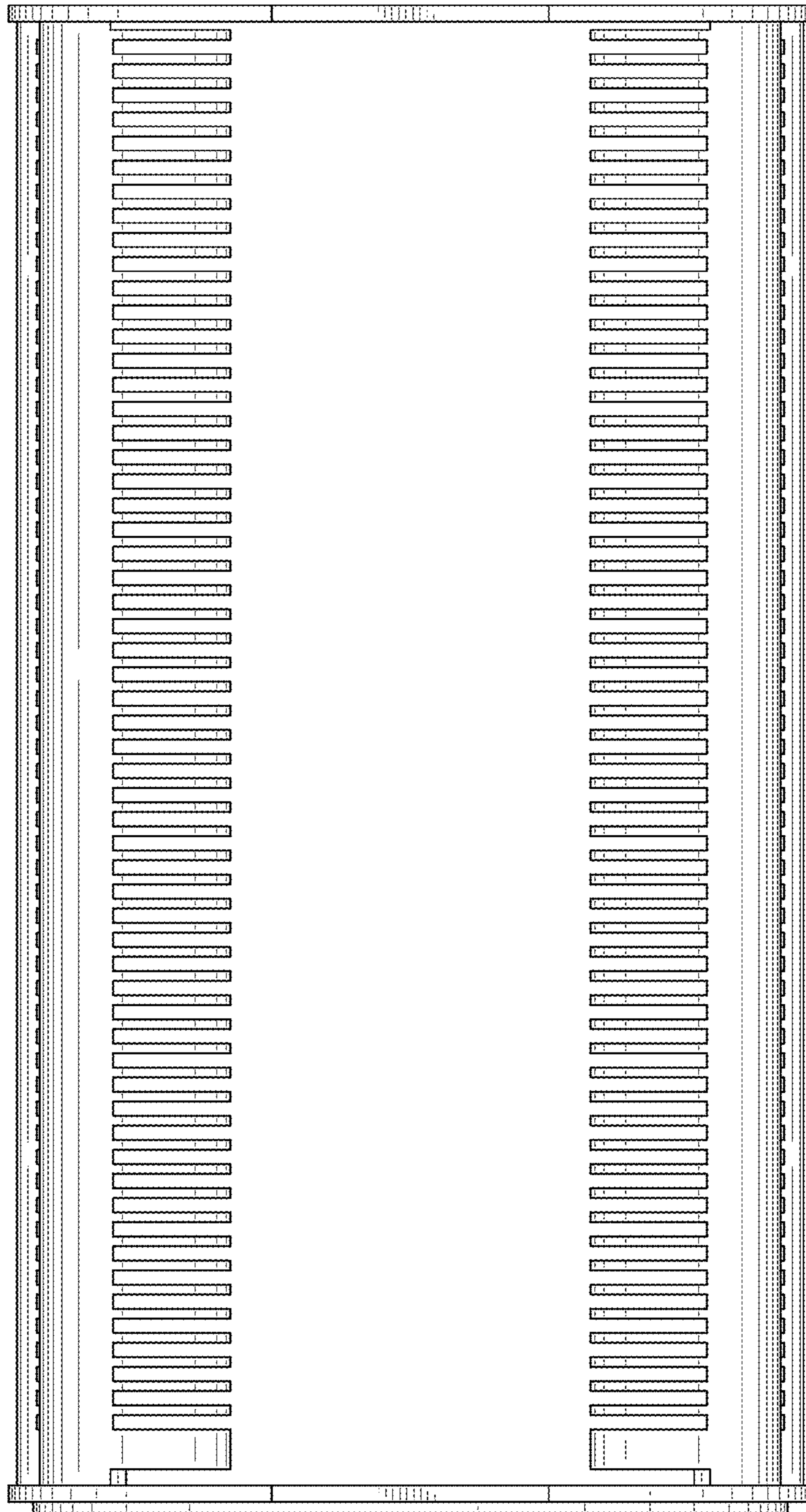


FIG. 4

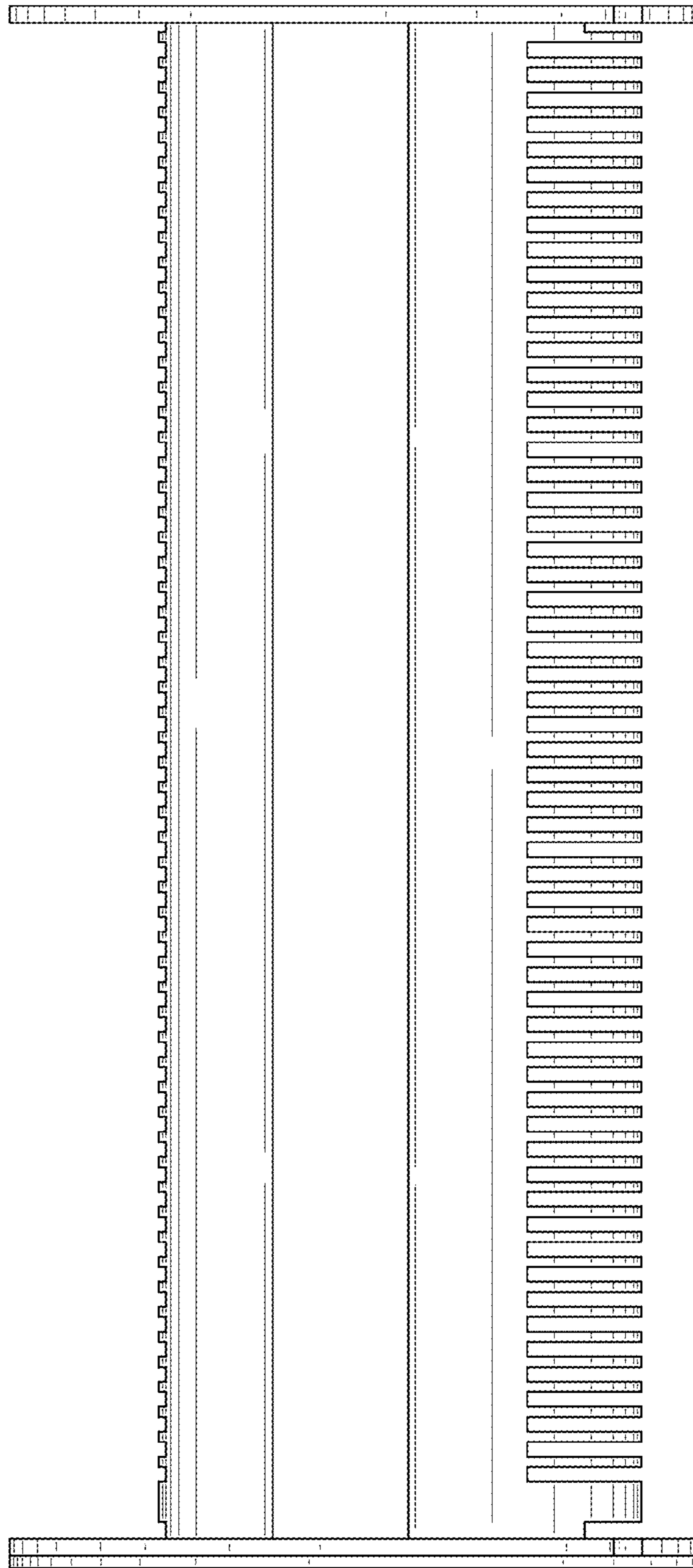


FIG. 5

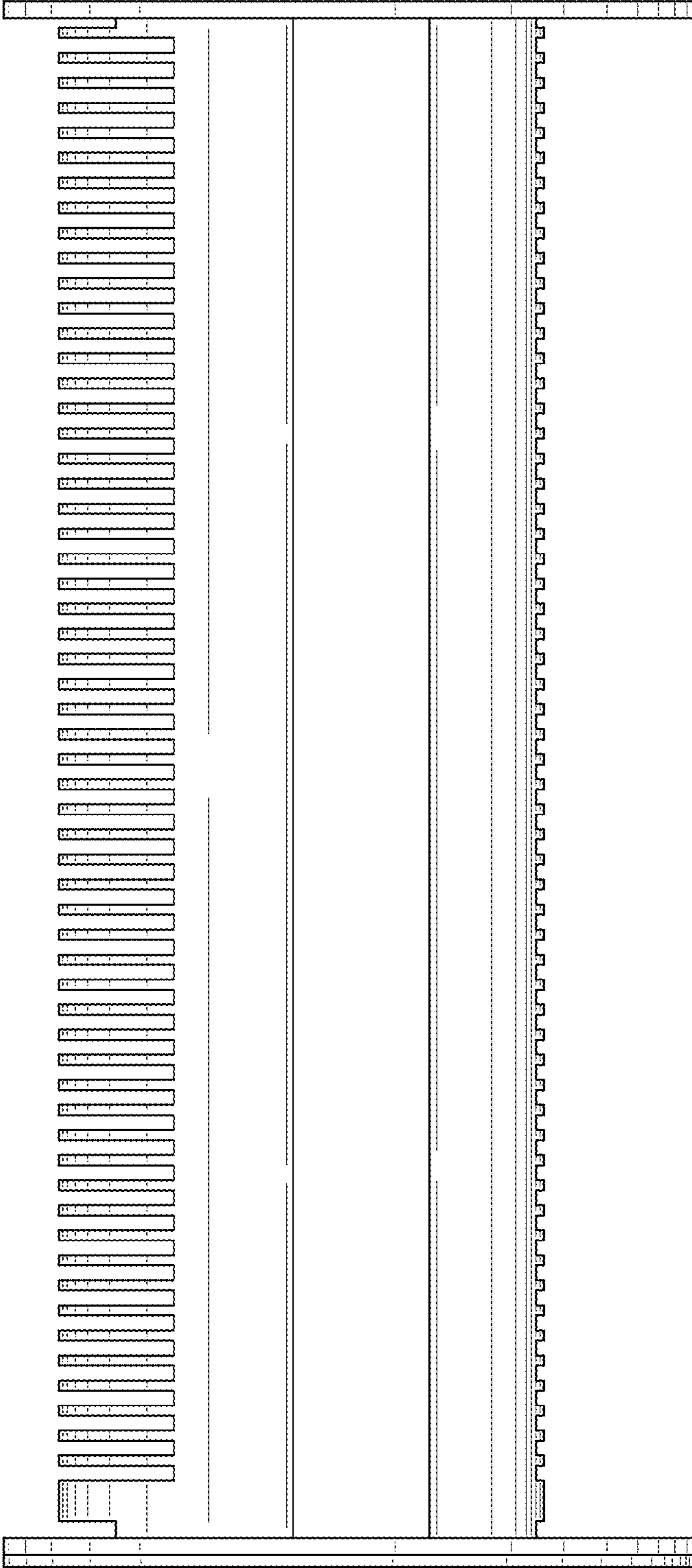


FIG. 6

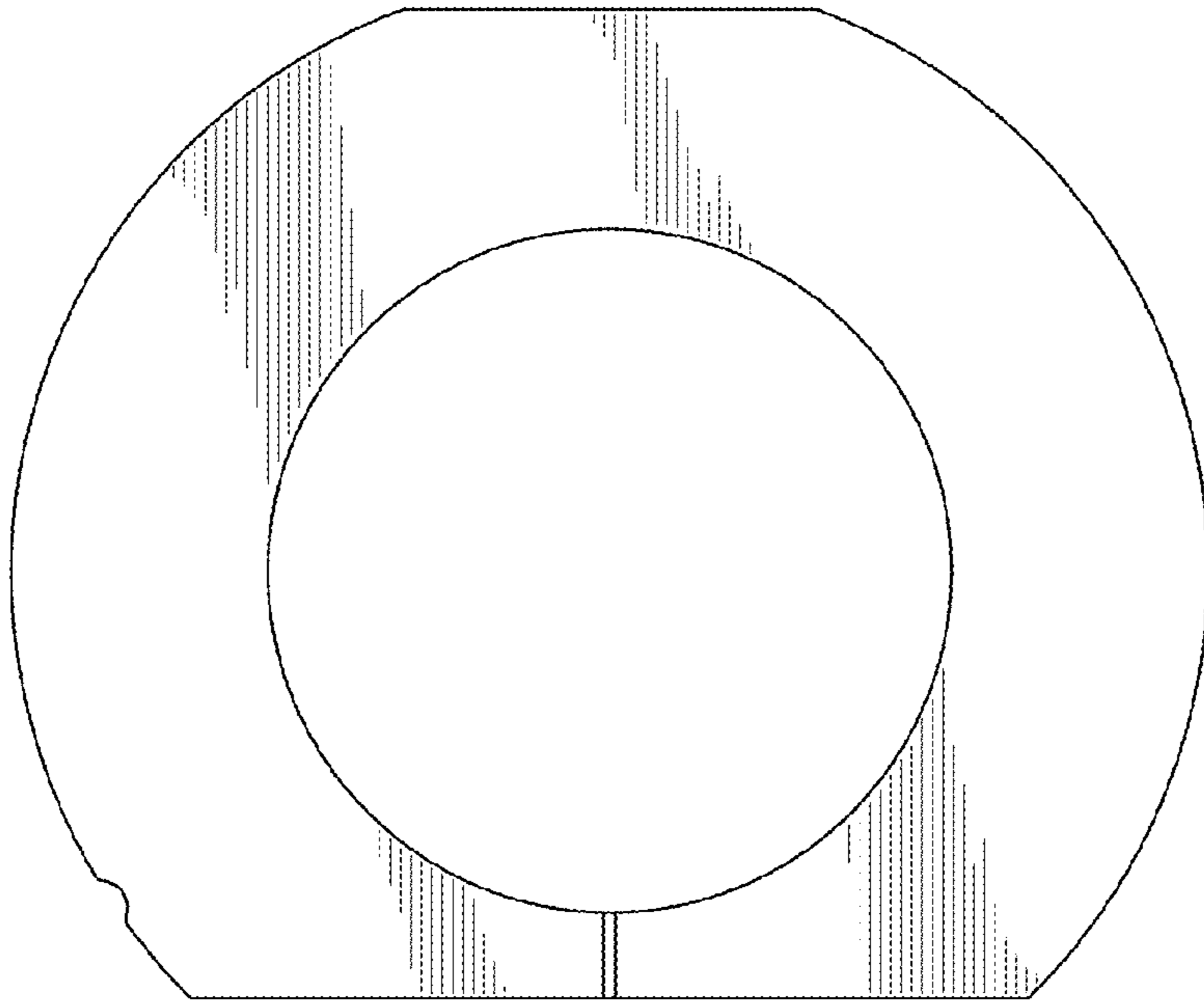


FIG. 7

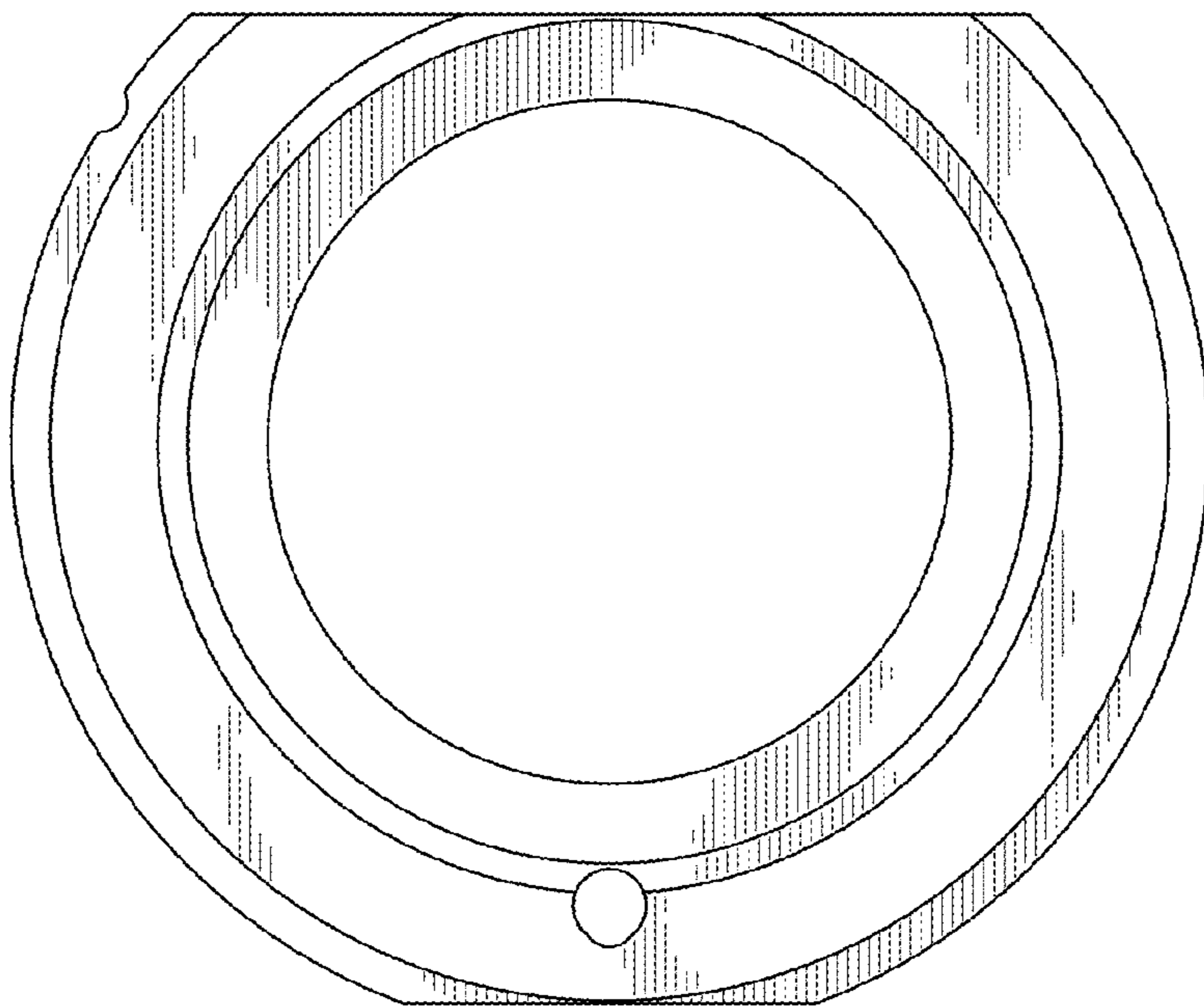


FIG. 8

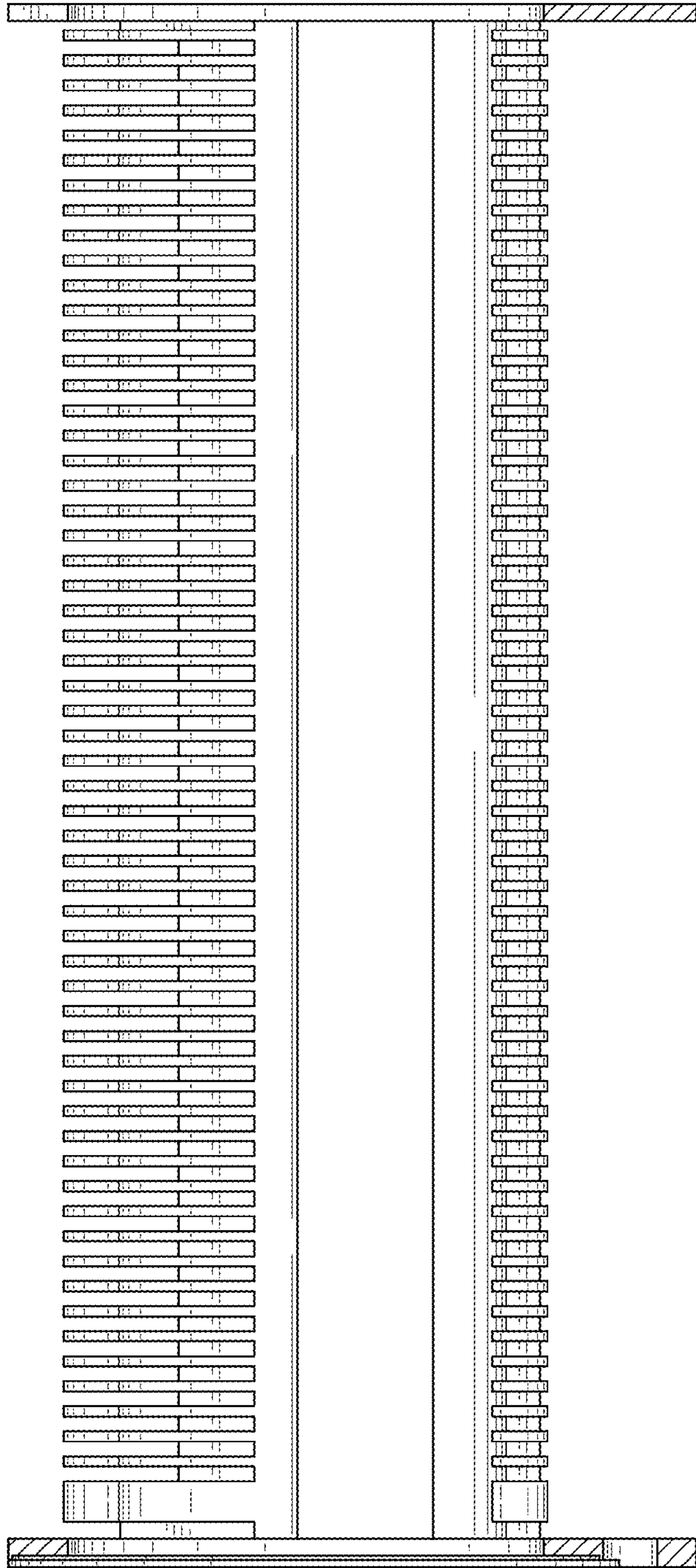


FIG. 9

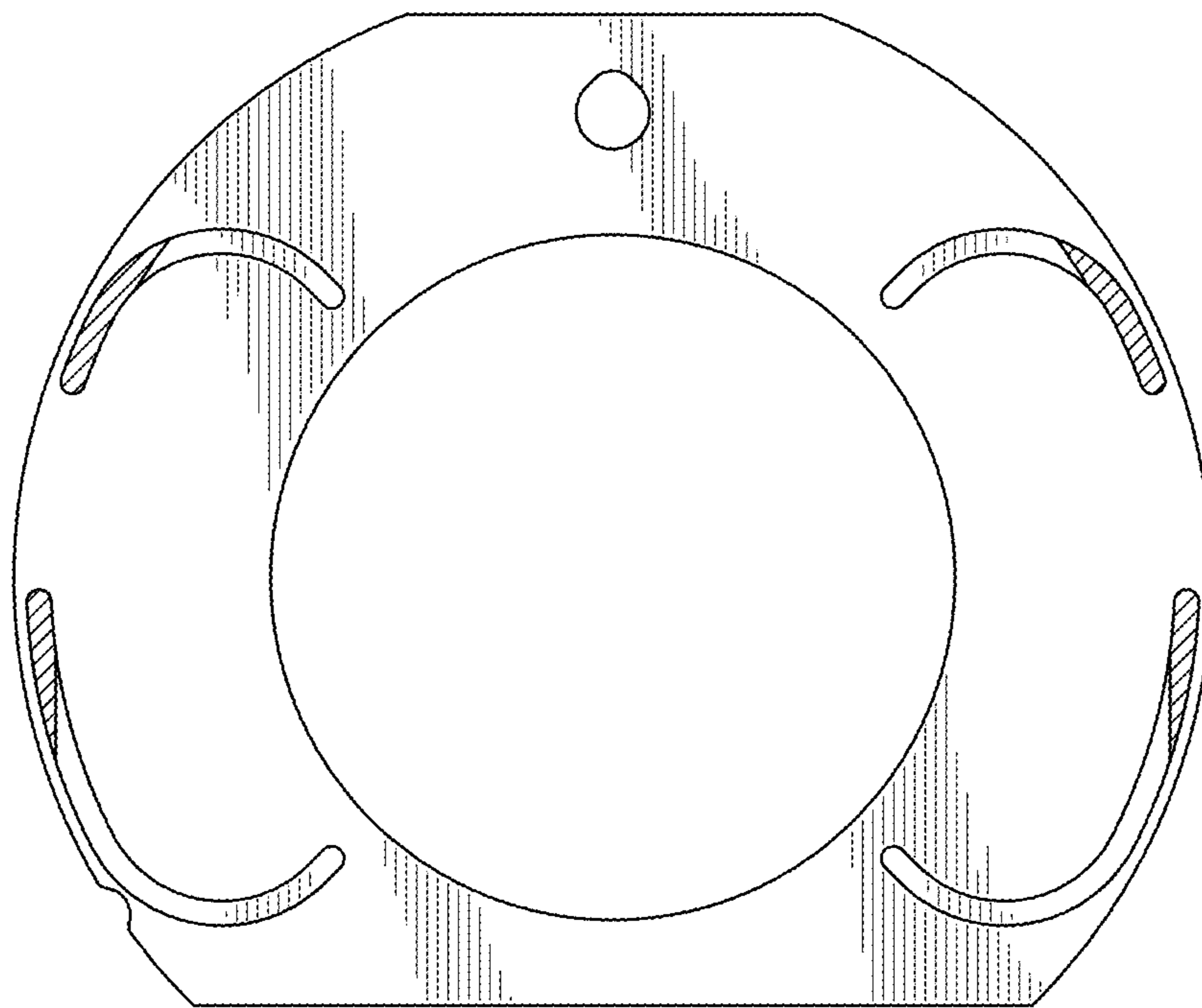


FIG. 10